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Docket No. 0756-2428

#6 6-11-03

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Osamu NAKAMURA et al.

Serial No. 10/056,055

Filed: January 28, 2002

For: SEMICONDCUTOR DEVICE AND)

MANUFACTURING METHOD OF)

THE SAME

Art Unit: 2811

Examiner: Unassigned

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on 10.101

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INFORMATION DISCLOSURE STATEMENT AND IDENTIFICATION OF COPENDING APPLICATION

)

Commissioner for Patents Washington, DC 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith attached Form PTO-1449 listing references known to Applicant and requests that these references be made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a). It is requested that the accompanying information disclosure statement be considered and made of record in the above-captioned application. To assist the Examiner, the documents are listed on the attached form PTO-1449. It is respectfully requested that the Examiner initial a copy of this form and return to the undersigned.

The Examiner's attention is directed to Application Serial No.08/784,293 filed January 16, 1997 entitled Fabrication Method of Semiconductor Device.

This Information Disclosure Statement is being submitted before the submission of a first Office Action and therefore, no fee is required.

Respectfully submitted,

Eric J. Robinson

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					Filing Date	January 28, 2002	
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		(use as many sheets a	is necessi	ary)	Group Art Unit	2811	
					Examiner Name	Unassigned	
	Sheet		of		Attorney Docket Number	0756-2428	

				U.S. PATENT DOCUMEN			
Examiner Initials	Cite No.1	U.S. Patent I	Document	Name of Patentee or Applicant of Cited	Date of Publication of Cited Document		
		Number	Kind Code ² (if known)	Document	- MM-DD-1111		_
		6,162,704		Yamazaki et al.	12/19/00		
		6,180,439		Yamazaki et al.	01/30/01		
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FOREIGN PATENT DOCUMENTS								
Examiner Initials	Cite No.1	Foreign Patent Document			Name of Patentee or	Date of Publication of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant	
		Office ³	Number ⁴	Kind Code ⁵ (if known)	Applicant of Cited Document	MM-DD-YYYY	Figures Appear	T ⁴
	<u> </u>		0	THER PRIOR	ART – NON PATENT LITE	RATURE DOCUMENTS		
Examiner Initials	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.)., date, page(s), volume-issue number(s), publisher, city and/or country where published.						
		Specification and drawings of Application Serial No. 08/784,293 filed January 16, 1997 entitled "Fabrication Method of Semiconductor Device," along with pending claims as of June 7, 2002						
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١	Examiner	Date	e
I	Signature	Con	nsidered

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^{*}EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹ Unique citation designation number. ² See attached Kinds of U.S. Patent Documents. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST.16 if possible. ⁶ Applicant is to place a check mark here if English language Translation is attached.

¹ Unique citation designation number. ² Applicant is to place a check mark here if English language Translation is attached.